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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q66498

Ichirou MIYAGAWA

Allowed: March 1, 2004

Appln. No.: 09/998,427 ✓

Group Art Unit: 2861

Confirmation No.: 5968

Examiner: Hai Chi Pham

Filed: December 03, 2001

For: MULTIBEAM EXPOSURE HEAD AND MULTIBEAM EXPOSURES APPARATUS

COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

MAIL STOP ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

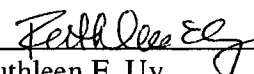
In response to the Examiner's Statement of Reasons for Allowance accompanying the Notice of Allowability dated March 1, 2004, Applicant submits the following comments:

COMMENTS

Applicant notes that the Examiner's particular comments regarding the reasons for allowance are not applicable to all of the independent claims. For example, the reasons for allowance of claim 2 includes features not explicitly included in the claim recitation.

Applicant further submits that the scope of the claims should be governed by the actual claim language and not by the Examiner's reasons for allowance.

Respectfully submitted,


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Date: April 30, 2004